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Attorney Docket No. 5308-127DV

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Allen et al.  
Application No.: 10/706,641  
Filed: November 12, 2003  
For: **METHODS OF FABRICATING SILICON CARBIDE METAL-  
SEMICONDUCTOR FIELD EFFECT TRANSISTORS**

Confirmation No.: 7025  
Group Art Unit: 2826  
Examiner: Ahmed N. Sefer

Date: November 10, 2004

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Attached is a list of a document on Form PTO-1449, together with a copy of the listed foreign patent document. It is requested that this document be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.56 and Section 609 of the MPEP.

No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted,

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**Certificate of Mailing under 37 CFR 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 10, 2004.

  
Erin A. Campion

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.